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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No. : 10/525,952  
Applicant : Detlev Wittmer et al.  
Filed : Feb. 28, 2005  
Art Unit : 2857  
Examiner : M. C. Baran  
Title : Method for monitoring sensor function  
Docket No. : WITT3004/FJD  
Customer No. : 23364

**RESPONSE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Introductory Comments**

The following amendments and remarks are being submitted herewith pursuant to the provisions of 37 CF 1.111 in response to the Office Action of September 15, 2009.